UNITED STATES PATENT AND TRADEMARK OFFICE

Bib Data Sheet

CONFIRMATION NO. 3358

SERIAL NUMBER 10/766,205	FILING DATE 01/28/2004 RULE	CLASS 438	GROUP ART UNIT 1763	ATTORNEY DOCKET NO. SC13121TP

APPLICANTS

Shahid Rauf, Pflugerville, TX;

Peter L.G. Ventzek, Austin, TX;
Wei E. Wu, Austin, TX;

** CONTINUING DATA ***********************   *gAg 5-05'*
gAg 5-05'

** FOREIGN APPLICATIONS *******************   *gAg 5-05'*

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
** 06/16/2004

Foreign Priority claimed ☐ yes ☒ no 35 USC 119 (a-d) conditions met ☐ yes ☒ no ☐ Met after Allowance Verified and Acknowledged Examiner's Signature *QA-8/5-05'* Initials	STATE OR COUNTRY TX	SHEETS DRAWING 3	TOTAL CLAIMS 22	INDEPENDENT CLAIMS 3

ADDRESS
23125
FREESCALE SEMICONDUCTOR, INC.
LAW DEPARTMENT
7700 WEST PARMER LANE MD:TX32/PL02
AUSTIN , TX
78729

TITLE
Method for etching a quartz layer in a photoresistless semiconductor mask

FILING FEE RECEIVED 806	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	☐ All Fees ☐ 1.16 Fees (Filing) ☐ 1.17 Fees (Processing Ext. of time) ☐ 1.18 Fees (Issue) ☐ Other _____ ☐ Credit